

Form 1449 (Modified)	Atty Docket No. IGT1P047	Application No.: 09/965,524
Information Disclosure Statement By Applicant	Applicant: Rick Rowe	Group 1256
(Use Several Sheets if Necessary)	Filing Date September 26, 2001	

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub- class	Filing Date
<i>max</i>	A1	6,149,522	11/21/00	Alcorn et al.	463	29	06/29/98
	A2	6,106,396	08/22/00	Alcorn et al.	463	29	06/17/96
	A3	6,104,815	08/15/00	Alcorn et al.	380	251	01/09/98
	A4	5,836,817	11/17/98	Acres et al.	463	26	06/06/95
	A5	5,643,086	07/01/97	Alcorn et al.	463	29	06/29/95
	A6	4,856,787	8/15/89	Itkis	273	237	5/3/88
	A7	5,800,269	09/01/98	Holch et al.	463	42	04/25/97
	A8	5,759,102	06/02/98	Pease et al.	463	42	02/12/96
	A9	5,702,304	12/30/97	Acres et al.	463	29	06/06/95
	A10	5,741,183	04/21/98	Acres et al.	463	42	06/06/95
	A11	5,752,882	05/19/98	Acres et al.	463	42	06/06/95
	A12	5,820,459	10/13/98	Acres et al.	463	25	06/06/95
	A13	5,876,284	03/02/99	Acres et al.	463	25	05/13/96
	A14	5,655,961	08/12/97	Acres et al.	463	27	10/12/94
	A15	5,761,647	6/2/98	Boushy	705	10	5/24/96
	A16	6,135,887	10/24/00	Pease et al.	463	42	6/1/98
	A17	5,941,947	8/24/99	Brown	709	255	8/18/95
	A18	5,923,885	7/13/99	Johnson et al.	395	712	10/31/96
	A19	4,558,413	12/10/85	Schmidt	364	300	11/21/83
	A20	4,335,809	6/22/82	Wain	194	1R	1/29/80
	A21	6,282,709	8/28/01	Reha et al.	717	11	11/12/97
	A22	6,266,810	7/24/01	Tanaka et al.	717	11	4/17/98
	A23	6,263,497	7/17/01	Maeda et al.	717	11	7/27/98
	A24	6,074,435	6/13/00	Rojestal	717	11	10/30/97
	A25	6,006,034	12/21/99	Heath et al.	395	712	9/5/96
	A26	5,999,740	12/7/99	Rowley	395	712	9/29/97
	A27	5,974,454	10/26/99	Apfel et al.	709	221	11/14/97
	A28	5,951,639	9/14/99	MacInnis	709	217	2/14/96
	A29	5,812,857	9/22/98	Nelson et al.	395	712	8/28/96

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

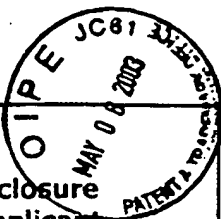
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Information Disclosure
Statement By Applicant

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Atty Docket No.
IGT1P047/P-529Applicant:
Richard E. RoweFiling Date
September 26, 2001Application No.:
09/965,524Group
2152

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	1A						
	2A						
	3A						
	4A						
	5A						
	6A						
	7A						

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
<i>MP</i>	1B	EP 1.004.970	5/31/2000	EPO	G 06F	17/60	xx	
<i>2</i>	2B	EP.1.004.696	5/31/2000	EPO	G 06F	17/60	xx	
	3B	EP 1.001.391	5/17/2000	EPO	G 07F	17/32	xx	
	4B							
	5B							
	6B							
	7B							
	8B							

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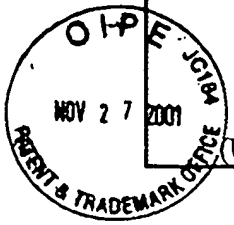
Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	1C	
	2C	
	3C	
	4C	

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Date Considered

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U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub- class	Filing Date
<i>mal</i>	A1	5,768,382	06/16/98	Schneier, et al	380	23	11/22/95
	A2	6,099,408	08/08/00	Schneier, et al	463	29	12/31/96
	A3	6,178,510	01/23/01	O'Connor, et al	713	201	09/04/97
	A4						
	A5						

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub- class	Translation	
							Yes	No
	B1							
	B2							

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	C1	
	C2	
	C3	
	C4	
	C5	
	C6	
	C7	
Examiner <i>mal</i>	Date Considered _____	

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